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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the patent application of)

Barbazette et al.)

Application No: 10/618,313)

Filing Date: July 10, 2003)

For: DATA COLLECTION AND DIAGNOSTIC)
SYSTEM FOR A SEMICONDUCTOR)
FABRICATION FACILITY)

Docket No. ASTGP120

Group Art Unit: 2121

Examiner: CHANG, S.

Date: September 2, 2008

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on September 2, 2008.

Signed: 

Melinda M. Ward

COMMUNICATION REGARDING STATEMENT UNDER 37 C.F.R. §3.73(b)-ESTABLISHING RIGHT OF ASSIGNEE TO TAKE ACTION and POWER OF ATTORNEY BY ASSIGNEE (REVOCATION OF PRIOR POWERS)

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

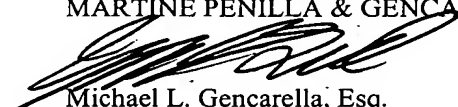
Applicant hereby attaches a Combined Statement Under 37 C.F.R. §3.73(b)-Establishing Right of Assignee to Take Action and Power of Attorney by Assignee of Entire Interest and Revocation of Prior Powers, and Appendix A, with reference to the above-identified U.S. patent application. Applicant respectfully requests this document be made of record.

As stated in the Power of Attorney please send all correspondence to:

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Applicant believes that no fees are due in connection with this filing, however, if it is determined that any fees are due, the Commissioner is authorized to charge such fees to Deposit Account 50-0805 (ASTGP120). If the Commissioner has any questions concerning this document, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,
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APPENDIX A

Application No: 10/618,313
Inventor: Barbazette et al.
Assignee: Asyst Technologies, Inc.
Title: Data Collection and Diagnostic System for a Semiconductor
Fabrication Facility

Recordation Date: February 9, 2004
Reel/Frame: 015714/0792
Atty Docket: ASTGP120